

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): H. SHISHIDO, et al

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Serial No.:

09/473,296

Filed:

December 28, 1999

GROUP 2700

For:

METHOD AND EQUIPMENT FOR DETECTING PATTERN

DEFECT

Group:

2785

Examiner:

## PRELIMINARY AMENDMENT

Commissioner for Patents Washington, D.C. 20231

July 20, 2000

sir:

. The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

## IN THE SPECIFICATION:

Please replace the original specification with the attached Substitute Specification.

## **BEST AVAILABLE COPY**

## IN THE CLAIMS:

Please amend the claims as follows:

Claim 1, line 2, before "laser" (first occurrence) insert

--a--; same line 2, delete "means";

line 4, delete "means";

line 14, delete/"detecting an";

line 15, delete "image of said sample".